

## PATENT NUMBER and ISSUE DATE

## U.S. UTILITY Patent Application

	APPL NUM	FILING DATE	l .	SUBCLASS	GAU	EXAMINER .					
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	**APPLICANT	APPLICANTS: Nakagawa Katsumi; Saito Tetsuro; Shoji Tatsumi; Yoshino Takehito; ishida Shoji; Ukiyo Noritaka; Iwane Masaaki; Mizutani Masaki;									
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	Foreign priority clai		Di Ves	RESCIN		ATTORNEY DOCKET NO					
١	35 USC 119 condit	ions met	□ yes	i 🗆 no		1					
1		rified and Acknowledged Examiners's intials 35.C16024  TLE: Liquid phase growth process, liquid phase growth system and substrate member production									
	nethod										
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NOTICE OF ALL	OWANCE MAILED		CLAIMS ALLOWED						
		Assistant Examiner	Total Claims		Print Claim for O.G				
ISS	UE FEE		DRAWING						
Amount Due	Date Paid	1	Sheets Drwg. Figs.t		g. Print Fig.				
	<u> </u>	Primary Examiner							
TERMINAL	PREPARED FOR ISSUE	Application Examiner							
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